

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/768,122	<b>Applicant(s)/Patent under Reexamination</b> LIN, CHAO-JEN
	<b>Examiner</b> Khoa D. Huynh	<b>Art Unit</b> 3751

**SEARCHED**

<b>INTERFERENCE SEARCHED</b>			
Class	Subclass	Date	Examiner